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I. INTRODUCTION

Ionizing radiations, such as X and Gamma rays, generate electron-hole pairs in the isolation oxides used in CMOS image sensors (CIS). This phenomenon leads to interface state generation and positive charge trapping in these oxides and can induce severe degradation of irradiated image sensors. Such radiation effects are known to be critical for imaging applications in ionizing environment such as space applications, medical imaging and particle detection. Important efforts have been made to understand and importantly reduce the effect of ionizing radiations on CMOS image sensors in the last decade [1-3]. However, the use of deep submicron technologies dedicated to imaging have brought new behaviors [4, 5] that need to be studied more in detail, especially at total ionizing dose above 1 kGy.

In this paper we present a study of ionizing radiation effects, up to 5 kGy, in several CMOS image sensors manufactured using a commercial 0.18 µm technology dedicated to imaging.

II. EXPERIMENTAL DETAILS

Ten 128x128-3T-pixel-CMOS image sensors, with different designs, have been manufactured and tested, before and after being irradiated with $^{60}$Co $\gamma$-rays. Several combinations of transistor threshold voltages ($V_t$) — standard (SdtVt), low Vt (LowVt) and zero Vt (0Vt) — have been used to design the sensor readout chains as illustrated in Tab. 1. N1, N2 and N3 are the in-pixel reset, source follower and switch N channel MOSFETs. After the double sample and hold stage, two simple switched P-MOST source followers are used at the bottom of each column. In Tab. 1, P1 and P2 represent the source follower P-MOST and the switch P-MOST respectively. One sensor (µLENS) has a microlens array on top. All the manufactured CIS have a 10 µm pixel pitch and a conversion factor around 8 µV/e, except the µLENS sensor which has a 7µm pixel pitch and a conversion factor about 14 µV/e.

III. OPTOELECTRICAL TRANSFER FUNCTION

For 650 nm photon wavelength, the two main radiation effects that can be seen on the optoelectrical transfer function after exposure to $\gamma$-rays (Fig. 1) are a dark current rise and a saturation voltage increase.

Fig. 2 shows that the main part of the saturation voltage increase is due to the variation of reset MOSFET threshold voltage and/or subthreshold current. Both these degradations can be attributed to shallow trench isolations according to previous work [6, 7].

Fig. 3 shows a minimum size N channel MOS transistor subthreshold characteristics for two drain to source voltages ($V_{DS}$) (0.5V and 3.3V) before and after 1 kGy irradiation. During the exposure to $\gamma$-rays, this transistor was pulsed in the same conditions than N1 MOSFET of the tested CIS. As expected from the sensor degradations, total ionizing dose led to a significant leakage current increase and a small threshold voltage decrease in the device. It is important to notice that the radiation induced subthreshold leakage current rises significantly when the drain to source voltage increases. $V_{DS}$ is lower when low Vt reset MOST is used instead of a standard Vt MOST. It can explain why sensors with standard Vt N1 (RD-A and RD-C) exhibit a larger saturation voltage increase in soft reset mode (Fig. 2) in comparison to CIS with low Vt N1 (RD-B and RD-D). In hard reset mode, standard Vt and low Vt reset MOSFETs behave the same since the reached reference voltage does not depend anymore on N1 threshold voltage and leakage current.
Above 1 kGy and below wavelength of 650 nm, ionizing radiations degrade significantly the tested image sensors responsivity as illustrated in Fig. 4. This degradation can be due to an interface state density increase, yielding to a surface recombination velocity increase, as mentioned by [3]. The result of an elementary simulation which estimates the effect of a radiation induced enhancement of the surface recombination velocity is also shown in Fig. 4. The good agreement between the data and the model strongly suggests that surface recombination enhancement, due to the generation of interface states, is most likely the only cause of this observed degradation. However, others phenomena can also explain this wavelength dependent responsivity degradation, such as the creation of color centers [8] in oxides as suggested in [4]. This may bring about a modification of the superficial layer stack transmission. Similar results can be observed on irradiated CIS with microlenses (Fig. 5). As for the REF#1 device, the responsivity at 450 nm is about 12% less after 1 kGy irradiation. It suggests that, up to 1 kGy, microlenses optical transmission does not seem to be degraded by the γ-rays.

Latest results, obtained on the RD-D device after 5 kGy irradiation (Fig. 6), show a decrease of the responsivity up to 20% at 400 nm (and 14% at 450 nm). Further characterizations on other devices are planned is the next future.

V. DARK CURRENT

As mentioned previously, the dark current rises greatly with total ionizing dose (Fig. 7). The linear dark current density increase is very sharp in comparison to the relatively low dark current density before exposure (4 A/µm).

According to previous work [5], this radiation induced dark current is a generation current proportional to the perimeter and is due to the surrounding STI. This is confirmed by the dark current activation energy extraction presented in Fig. 8 and Fig. 9. Before irradiation (Fig. 8), the large activation energy spreading suggests more complex mechanisms than a pure ideal generation current due to midgap centers. A slight electric field enhancement [9], a non uniform defect energy distribution or a significant diffusion current contribution [10] could explain the observed distribution. After 1 kGy (Fig. 9), the activation energy distribution converge clearly around 0.65 eV which is close to the value usually observed for pure radiation induced generation current in irradiated silicon devices (0.63 eV) [1].

VI. CONCLUSION AND FUTURE WORK

Despite the intrinsic hardness of deep submicron MOSFET gate oxides due to their reduced thickness, image sensors manufactured in deep submicron CMOS technologies still exhibit significant degradations when...
exposed to ionizing radiations. The dark current and the saturation voltage rose in the tested sensors, and these effects were attributed to the shallow trench isolations. Such effects can be mitigated in MOSFETs by the use of enclosed layout transistors and their use is recommended for total ionizing doses greater than 1 kGy. In terms of responsivity, a wavelength dependent decrease is observed on image sensors, with or without microlenses. This can be due to an increase of surface recombination velocity, as shown by our elementary simulation, and/or a change in the superficial layers stack transmittance. As regards the dark current, radiation hard photodiodes which can be used in any commercial deep submicron CIS process are still under study.

These results are likely to be transposable to 4T pinned photodiode based CIS. In order to confirm this point, such devices are being characterized for similar irradiation tests.

REFERENCES